15750 U.S. PTO



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In 22 704 In 122 Patent Application of: Kie Y. Ahn et al.

Title: LANTHANIDE DOPED TiOx DIELECTRIC FILMS

Attorney Docket No.:

1303.070US2

Customer No.: 21186

PATENT APPLICATION TRANSMITTAL

MAIL STOP PATENT APPLICATION

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

We are transmitting herewith the following attached items and information (as indicated with an "X"):

- X Return postcard.
- X DIVISIONAL of prior Patent Application No.(10/219878) (under 37 CFR 1.53(b)) comprising:
 - \underline{X} Specification (35 pgs, including claims numbered $\underline{1}$ through $\underline{40}$ and a $\underline{1}$ page Abstract).
 - X Formal Drawing(s) (7 sheets).
 - X Copy of signed Declaration (6 pgs) from prior application.
 - X Copy of Power of Attorney from prior application ($\frac{1}{2}$ pgs).
 - Incorporation by Reference: The entire disclosure of the prior application, from which a copy of the oath or declaration is supplied herewith, is considered as being part of the disclosure of the accompanying application and is hereby incorporated by reference therein.
 - X Check in the amount of \$1560.00 to pay the filing fee.
- X Prior application is assigned of record to Micron Technology, Inc..
- \underline{X} Information Disclosure Statement ($\underline{1}$ pgs), Form 1449 ($\underline{6}$ pgs) References NOT enclosed, cited in prior application.
- X Communication Concerning Related Applications (3 pgs.).

The filing fee has been calculated below as follows:

No. Filed	No. Extra	Rate	Fee	
40-20	20	x 18.00 =	\$360.00	
8-3	5	x 86.00 =	\$430.00	
[] MULTIPLE DEPENDENT CLAIMS PRESENTED				
BASIC FEE				
TOTAL				
	40-20 8-3 EPENDENT C BASIC FE	40-20 20 8-3 5 EPENDENT CLAIMS PRESENT BASIC FEE	40-20 20 x 18.00 = 8-3 5 x 86.00 = EPENDENT CLAIMS PRESENTED BASIC FEE	

Please consider this a PETITION FOR EXTENSION OF TIME for sufficient number of months to enter these papers. Please charge any additional required fees or credit overpayment to Deposit Account No. 19-0743.

SCHWEGMAN, LUNDBERG, WOESSNER & KLUTH, P.A.

Customer Number: 21186

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Reg. No. 46,632

"Express Mail" mailing label number: EV299684065US

Date of Deposit: February 27, 2004

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S/N Unknown PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:

Kie Y. Ahn et al.

Examiner: Unknown

Serial No.:

Unknown

Group Art Unit: Unknown

Filed:

Herewith

Docket: 1303.070US2

Title:

LANTHANIDE DOPED TIOX DIELECTRIC FILMS

COMMUNICATION CONCERNING RELATED APPLICATION(S)

MS Patent Application Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Applicants would like to bring to the Examiner's attention the following related application(s) in the above-identified patent application:

<u>Serial/Patent No.</u> 09/944981	Filing Date August 30, 2001	Attorney Docket 1303.021US1	Title CRYSTALLINE OR AMOPHOUS MEDIUM-K GATE OXIDES, Y203 AND Gd203
09/945535	August 30, 2001	1303.026US1	HIGHLY RELIABLE AMORPHOUS HIGH-K GATE OXIDE ZrO2
10/028643	December 20, 2001	1303.030US1	LOW-TEMPERATURE GROWN HIGH QUALITY ULTRA-THIN CoTiO3 GATE DIELECTRICS
10/052983	January 17, 2002	1303.031US1	HIGHLY RELIABLE AMORPHOUS HIGH-k GATE DIELECTRIC ZrOxNy
10/027315	December 20, 2001	1303.033US1	LOW-TEMPERATURE GROWN HIGH- QUALITY ULTRA-THIN PRASEODYMIUM GATE DIELECTRICS
10/099194	March 13, 2002	1303.044US1	EVAPORATION OF Y-Si-O FILMS FOR MEDIUM-k DIELETRICS
10/081439	February 20, 2002	1303.046US1	EVAPORATED LaAIO3 FILMS FOR GATE DIELECTRICS
10/137058	May 2, 2002	303.802US1	ATOMIC LAYER DEPOSITION AND CONVERSION

COMMUNICATION CONCERNING RELATED APPLICATIONS

Serial Number: Unknown
Filing Date: Herewith
Title: LANTHANIDE DOPED TIOX DIELECTRIC FILMS

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10/137168	May 2, 2002	1303.048US1	METHODS FOR ATOMIC-LAYER DEPOSITION OF ALUMINUM OXIDES IN INTEGRATED CIRCUITS
10/137499	May 2, 2002	1303.050US1	ATOMIC LAYER-DEPOSITED LaAlO3 FILMS FOR GATE DIELETRICS
10/163481	June 5, 2002	1303.056US1	ATOMIC LAYER-DEPOSITED HfAIO3 FILMS FOR GATE DIELECTRICS
10/163686	June 5, 2002	1303.059US1	Pr2O3-BASED La-oxide GATE DIELECTRICS
10/219870	August 15, 2002	1303.069US1	LANTHANIDE DOPED TIOX DIELECTRIC FILMS BY PLASMA OXIDATION
10/219878	August 15, 2002	1303.070US1	LANTHANIDE DOPED TIOX DIELECTRIC FILMS
10/229903	August 28, 2002	1303.078US1	ATOMIC LAYER DEPOSITED HISION DIELECTRIC FILMS
10/233309	August 29, 2002	1303.079US1	ATOMIC LAYER DEPOSITED LANTHANIDE DOPED TIOX DIELECTRIC FILMS
10/309583	December 4, 2002	1303.082US1	ATOMIC LAYER DEPOSITED ZR-SN- TI-O FILMS USING TiI4
10/309935	December 4, 2002	1303.083US1	ATOMIC LAYER DEPOSITED Zr-Sn-Ti-O FILMS
10/379470	March 4, 2003	1303.090US1	ATOMIC LAYER DEPOSITED DIELECTRIC LAYERS
10/403734	March 31, 2003	1303.092US1	ATOMIC LAYER DEPOSITED ZrAlxOy DIELECTRIC LAYERS
10/420307	April 22, 2003	1303.097US1	ATOMIC LAYER DEPOSITED ZrTiO4 FILMS
10/602323	June 24, 2003	1303.101US1	LANTHANIDE OXIDE / HAFNIUM OXIDE DIELECTRIC LAYERS

Serial Number: Unknown Filing Date: Herewith

Title: LANTHANIDE DOPED TIOX DIELECTRIC FILMS

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LANTHANIDE OXIDE / HAFNIUM 1303.107US1 10/602315 June 24, 2003 **OXIDE DIELECTRICS** 09/838335 April 20, 2001 June 13, 09/881408 2001 09/908767 July 18, 2001 LOW-TEMPERATURE GROWN HIGH-10/765619 January 27, 1303.033US2 **QUALITY ULTRA-THIN** 2004 PRASEODYMIUM GATE **DIELECTRICS** LOW-TEMPERATURE GROWN HIGH-10/768597 January 30, 1303.033US3 2004 **QUALITY ULTRA-THIN** PRASEODYMIUM GATE **DIELECTRICS** Unknown Formation of Metal Oxide Gate Dielectric 09/779959 February 2, 2001

Respectfully submitted,

KIE Y. AHN ET AL.

By Applicants' Representatives,

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